

2822

Applicant: Qing Ma

Title: METHOD OF FABRICATING AN INTEGRATED CIRCUIT HAVING A MEMS DEVICE

Docket No.: 884.591US1

Filed: November 2, 2001

Examiner: Jamie L. Brophy

Serial No.: 10/005667

Due Date: February 26, 2003

Group Art Unit: 2822



Commissioner for Patents  
Washington, D.C. 20231

We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ A return postcard.
- ☒ Response to Restriction Requirement (1 pg.).
- ☒ Notification of Correspondence Address (1 pg.).

Please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

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By: Ann M. McCrackin  
Atty: Ann M. McCrackin  
Reg. No. 42,858

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on this 26th day of February, 2003.

Anne M. Richards

Name

Anne M. Richards  
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